Symposium (Oral) | Symposium: 【Open Symposium】 A Future Opened by Cutting-edge Semiconductors - Expectations for Applied Physics -

Mon. Sep 16, 2024 1:30 PM - 4:30 PM JST | Mon. Sep 16, 2024 4:30 AM - 7:30 AM UTC **A** A24 (TOKI MESSE 2F)

[16p-A24-1~8] (Open Symposium) A Future Opened by Cutting-edge Semiconductors - Expectations for Applied Physics -

Takao Someya(The Univ. of Tokyo)

 $2:05\ \mbox{PM}$ - $2:20\ \mbox{PM}$ JST | $5:05\ \mbox{AM}$ - $5:20\ \mbox{AM}$ UTC [16p-A24-4] Development of stacked CMOS image sensors

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Keywords: image sensor、stacked structure、through silicon via

CMOS image sensors, which are the imaging devices used in cameras, have seen a significant shift towards a "stacked" structure in recent years, bringing about major advancements in imaging and recognition capabilities in smartphones and automotives. In this presentation, I will explain the concept behind the development of stacked CMOS image sensors and discuss their advantages and effects.